

Notice of References Cited	Application/Control No. 10/642,674	Applicant(s)/Patent Under Reexamination HONG ET AL.	
	Examiner Kim-Kwok CHU	Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,137,754	10-2000	Furukawa et al.	369/44.32
*	B	US-6,041,030	03-2000	Ohmi, Takao	369/53.19
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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